

## Electronic Patent Application Fee Transmittal

Application Number:	10660813			
Filing Date:	12-Sep-2003			
Title of Invention:	Reactive ion etching for semiconductor device feature topography modification			
First Named Inventor:	Hemant P. Mungekar			
Filer:	Patrick Maurice Boucher/Nina McNeill			
Attorney Docket Number:	A8067/T51700			
Filed as Large Entity				
<b>Utility Filing Fees</b>				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
Request for continued examination	1801	1	790	790
<b>Total in USD (\$)</b>				<b>790</b>